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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	TZE-CHIANG CHEN, ET AL.	) Group Art Unit: 1765
Serial No.:	10/082,648	) )
Filed:	February 22, 2002	Examiner: Deo, D.
For:	DEEP TRENCH ISOLATION OF EMBEDDED DRAM FOR IMPROVED	) Confirmation No.: 6800

## **AMENDMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In response to the Office Action mailed May 6, 2004, please amend the Application as follows: